

<b>Notice of References Cited</b>	Application/Control No. 10/750,575	Applicant(s)/Patent Under Reexamination HONG, HYUNG KI	
	Examiner (Nancy) Thanh-Nhan P. Nguyen	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0043315	03-2003	Umemoto et al.	349/65
*	B	US-2003/0218701	11-2003	Kawakami, Hisanori	349/65
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
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	R					
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**NON-PATENT DOCUMENTS**

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